

# Sensores y Laboratorio 2019-I

Ing. Juan Ricardo Clavijo Mendoza MSc.

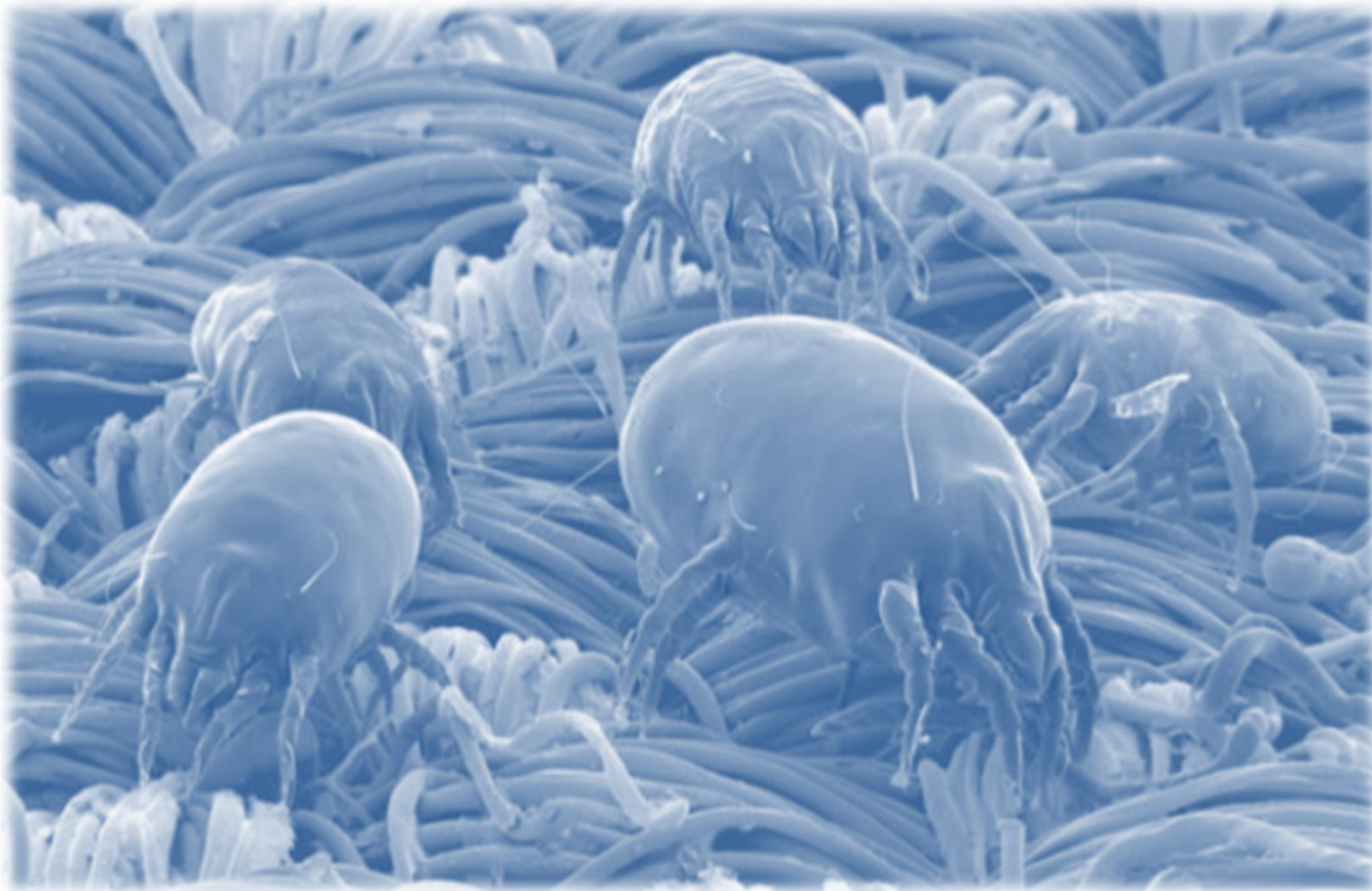
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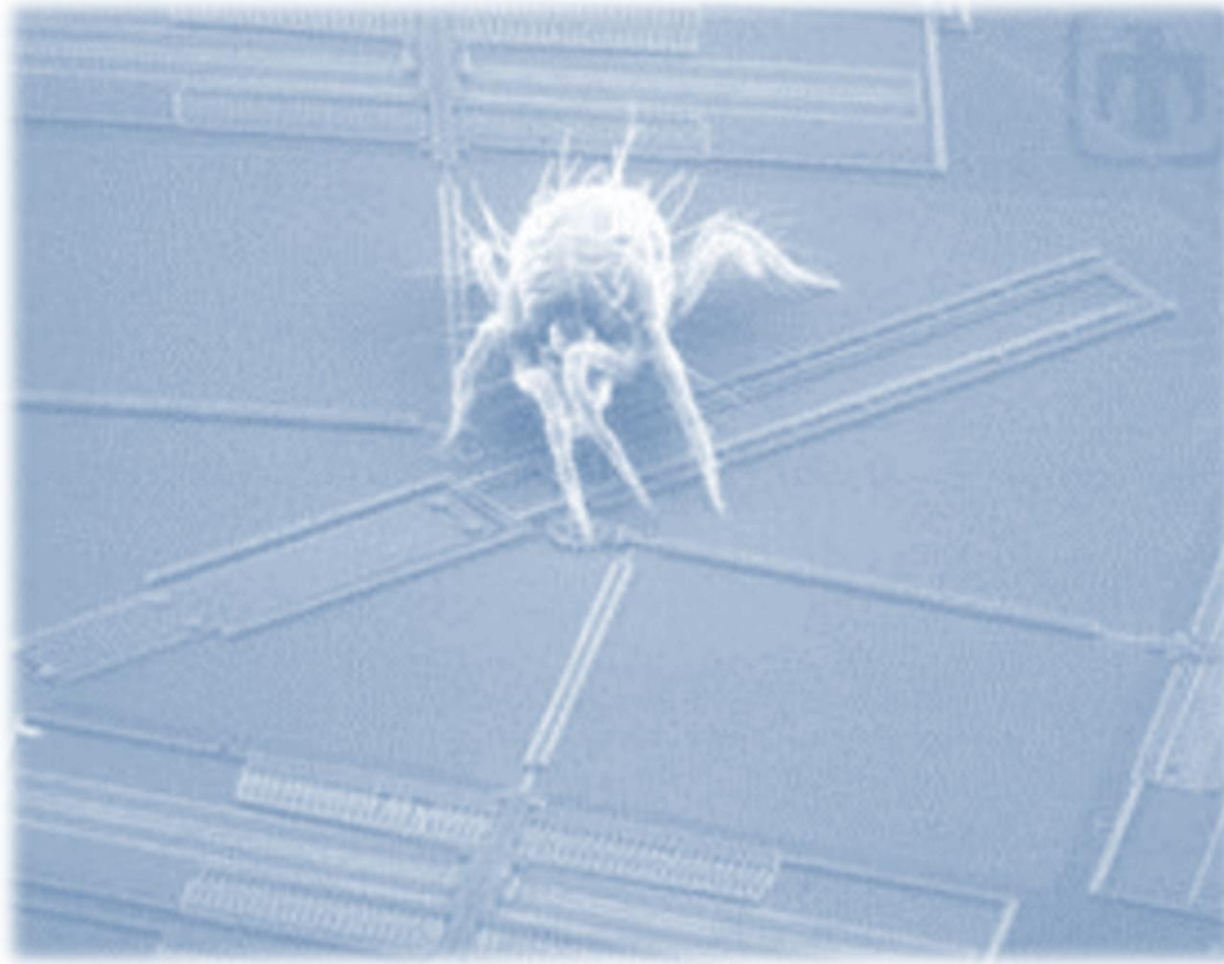




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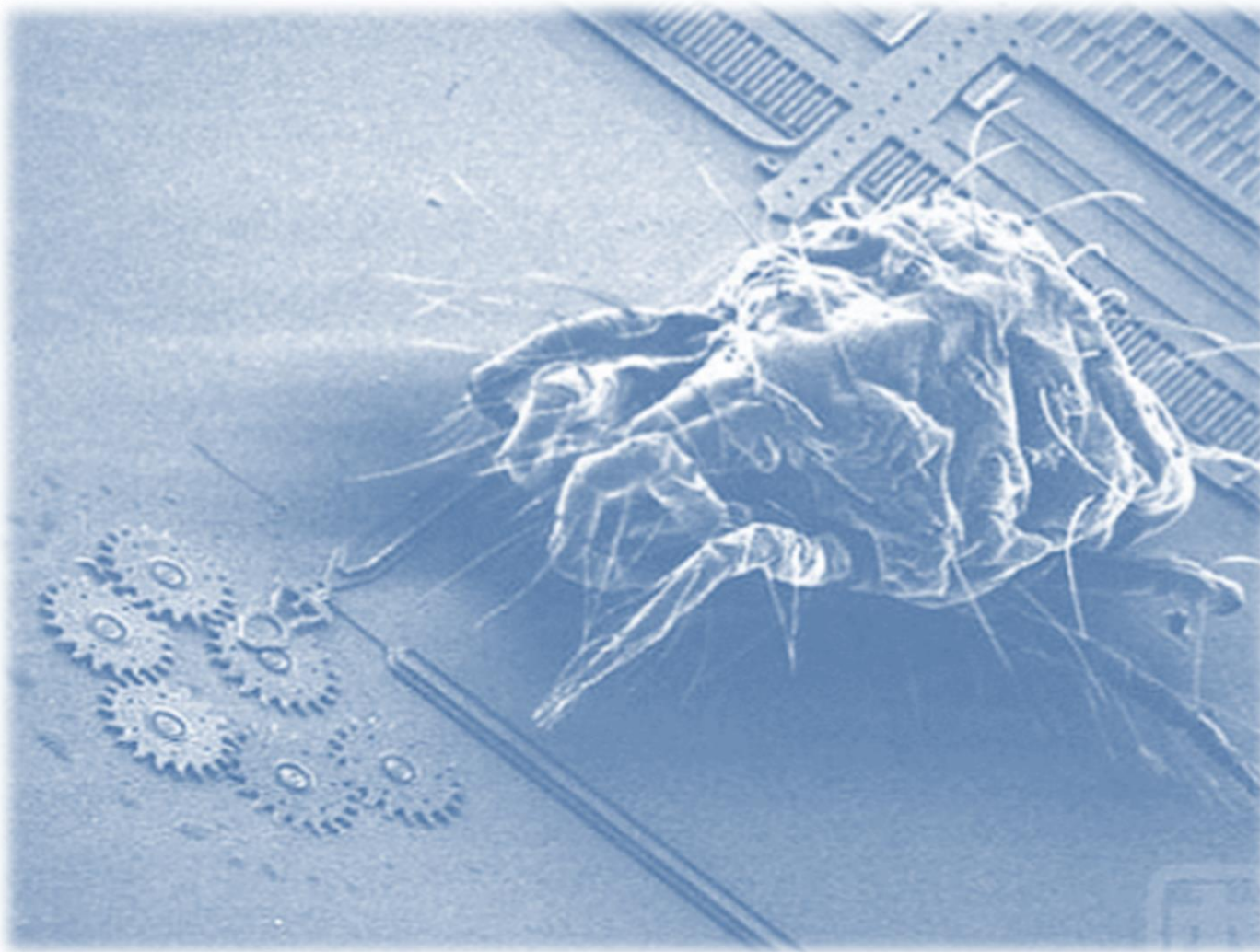


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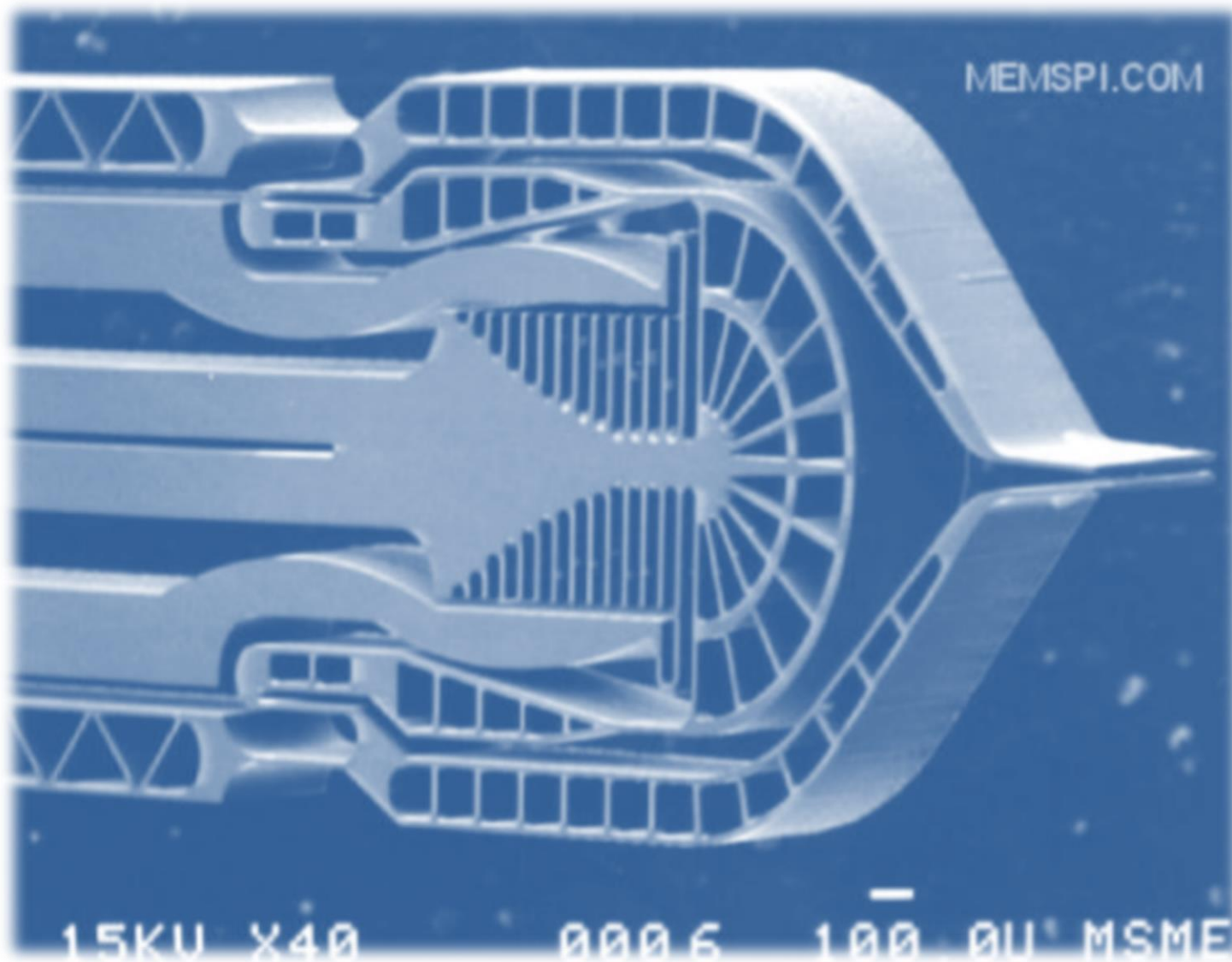




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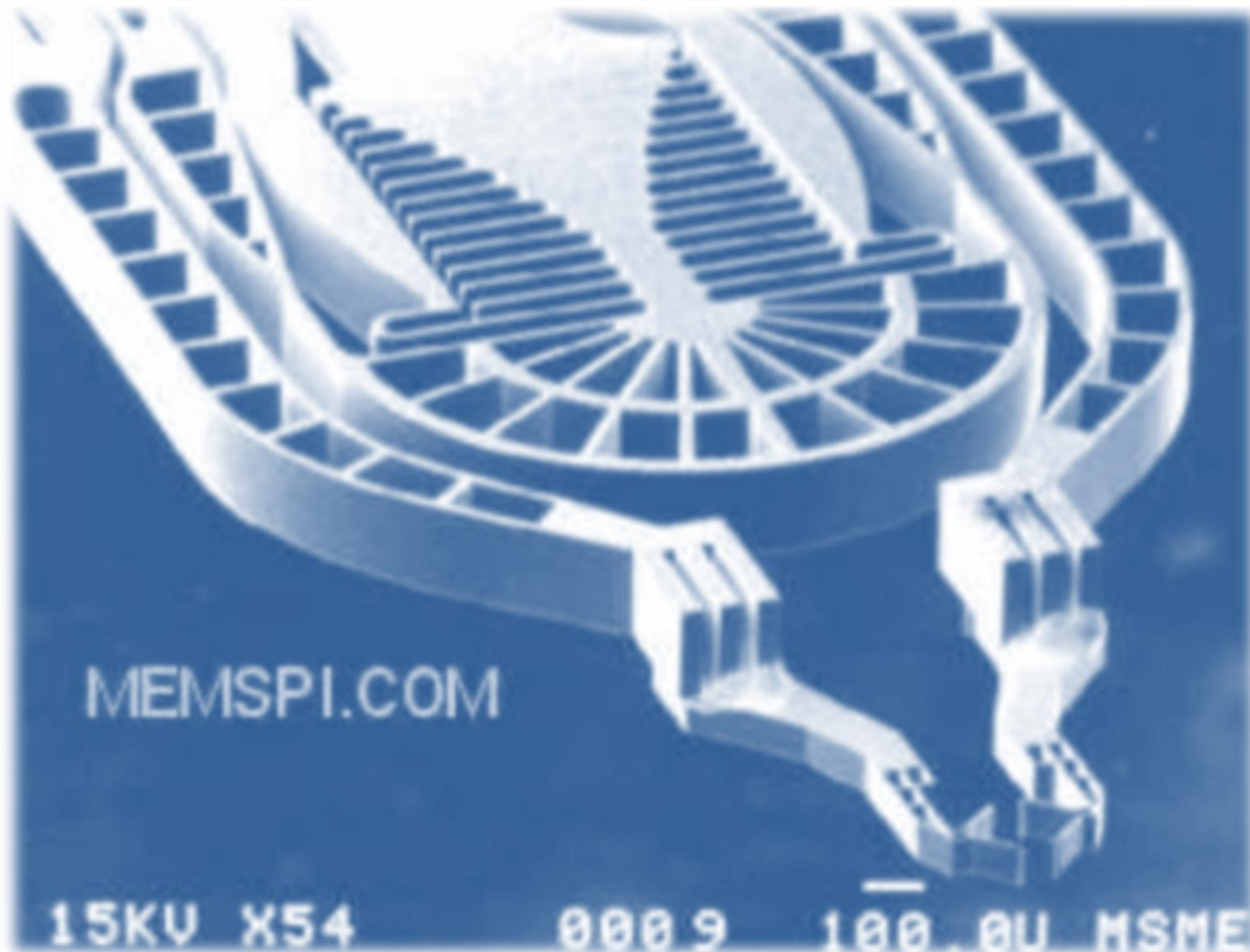


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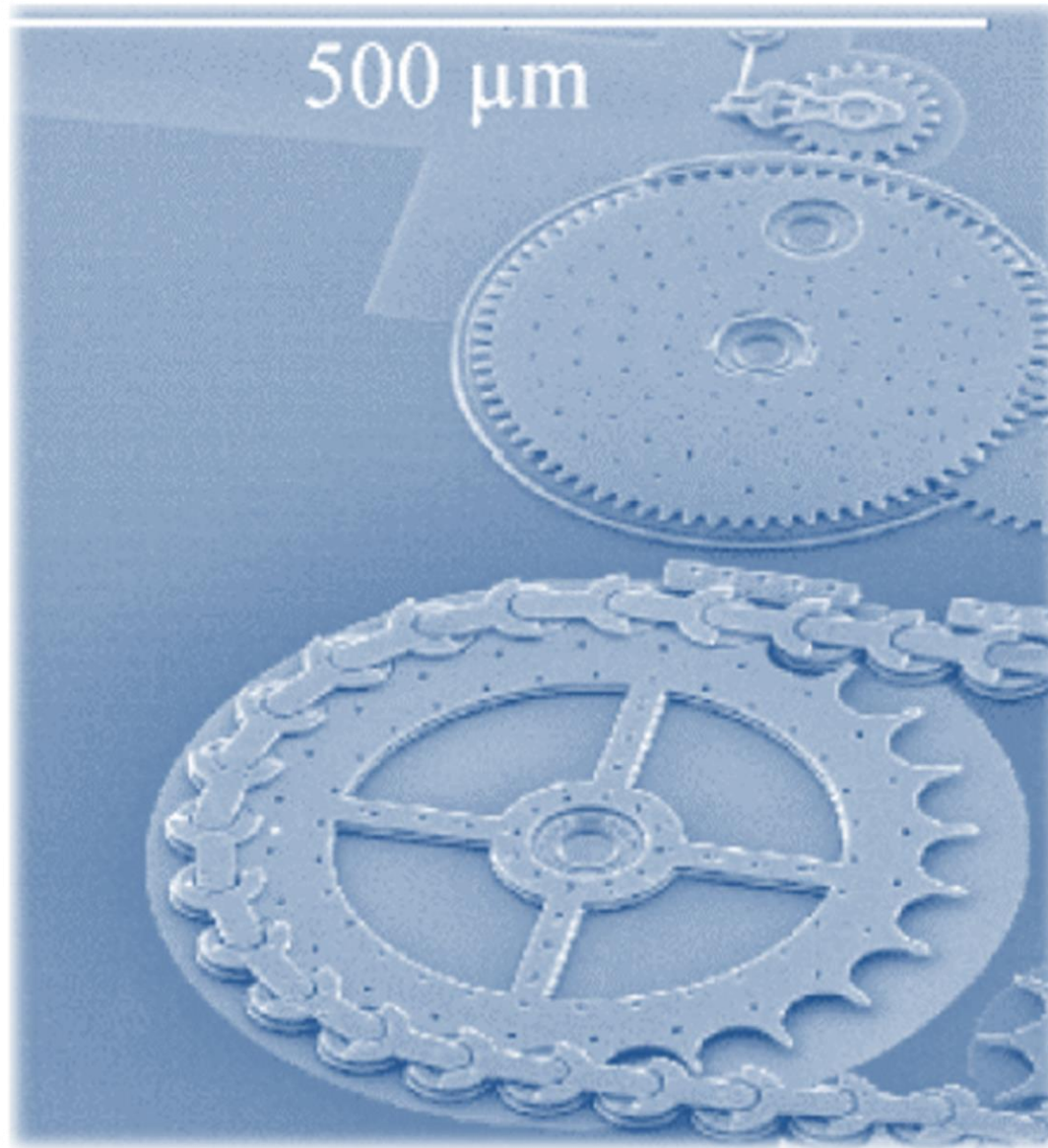


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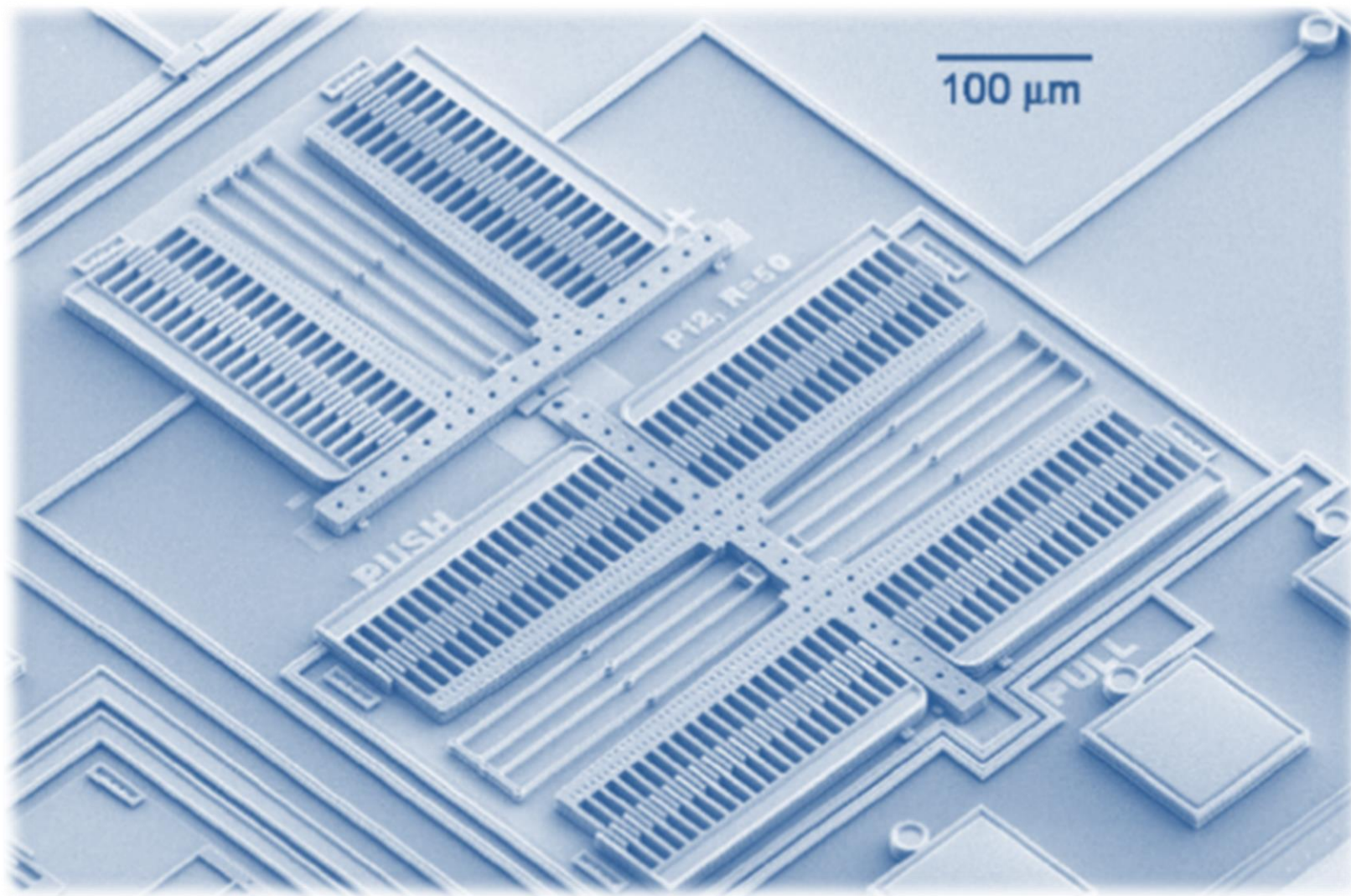




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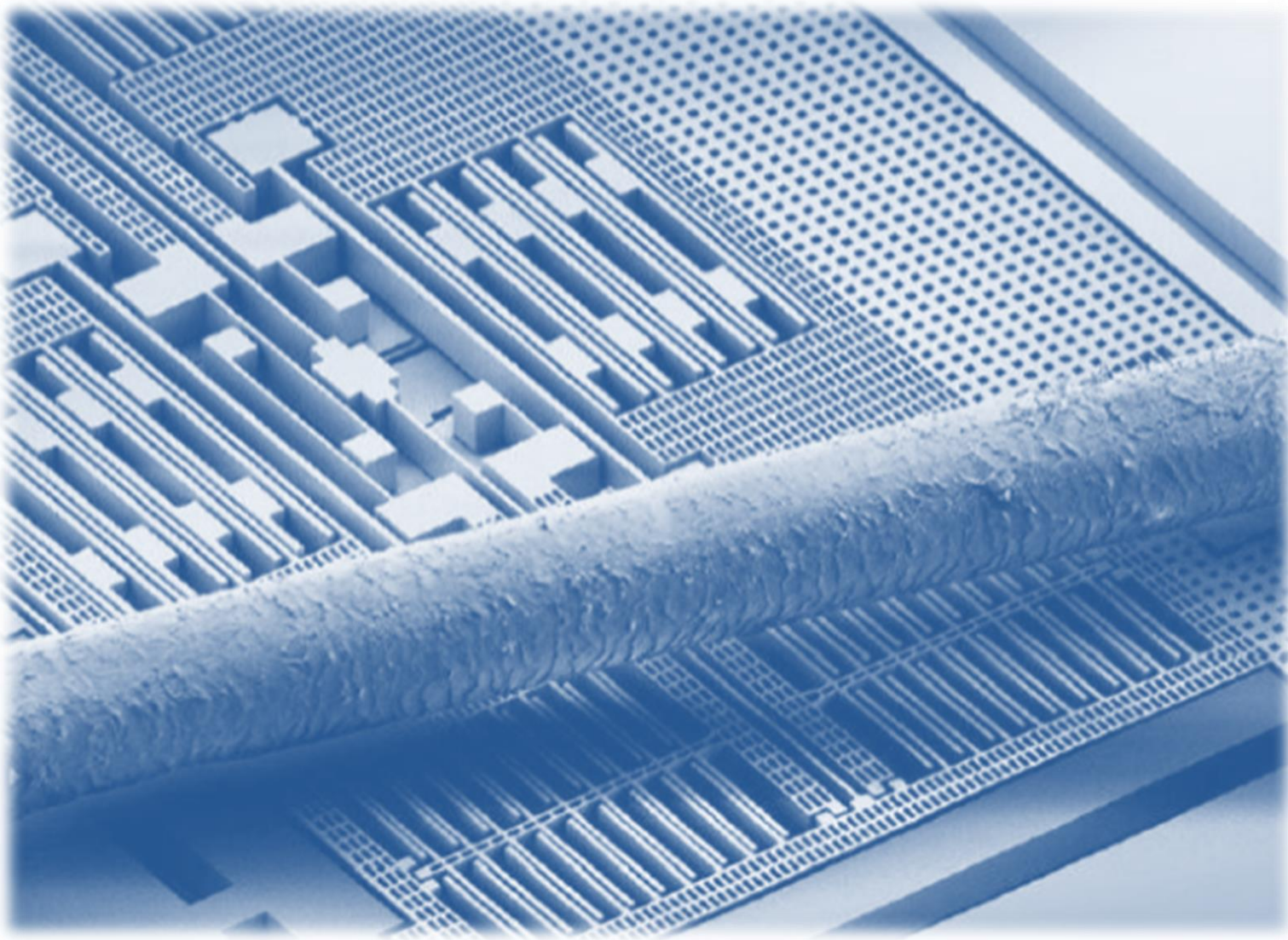


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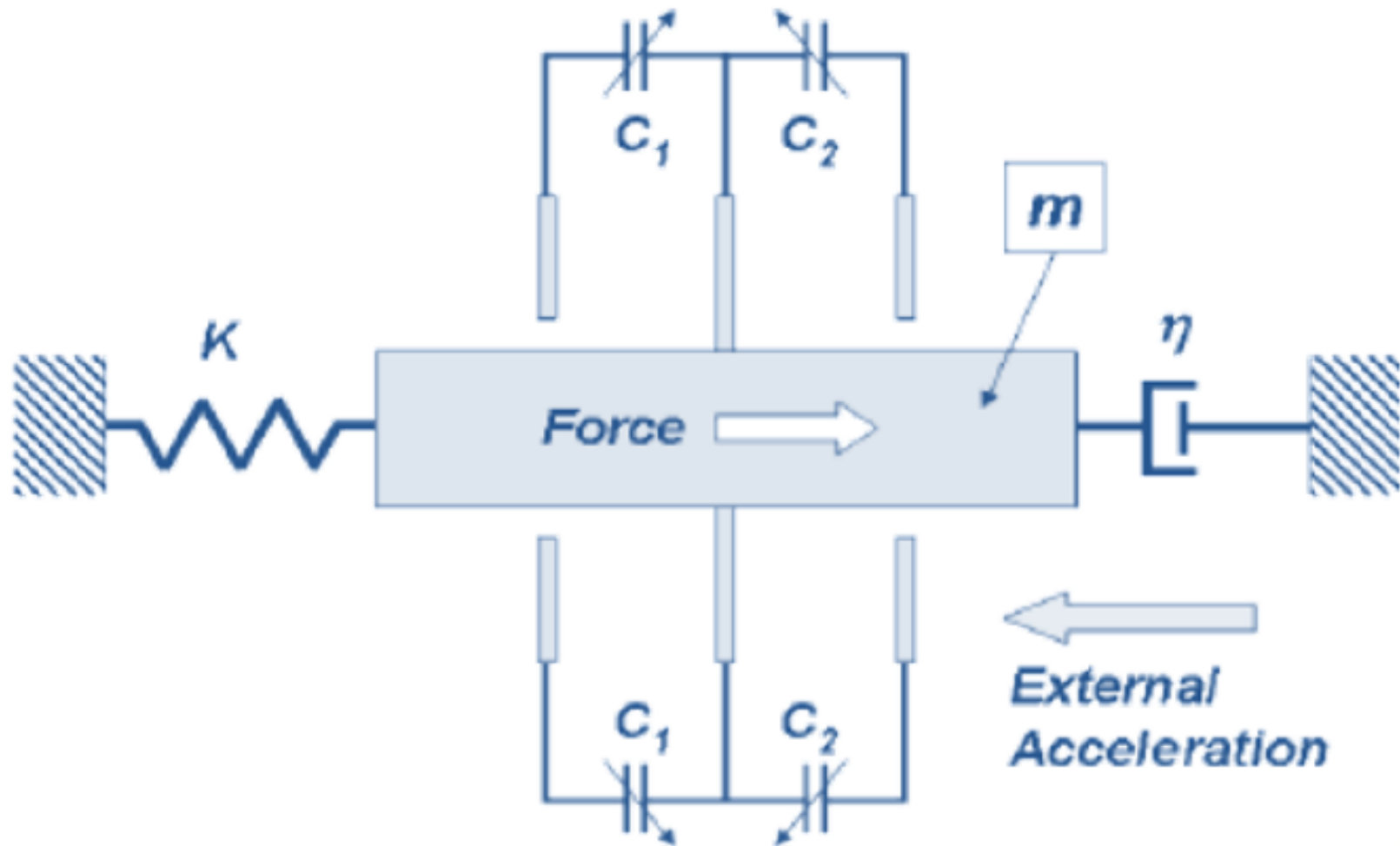




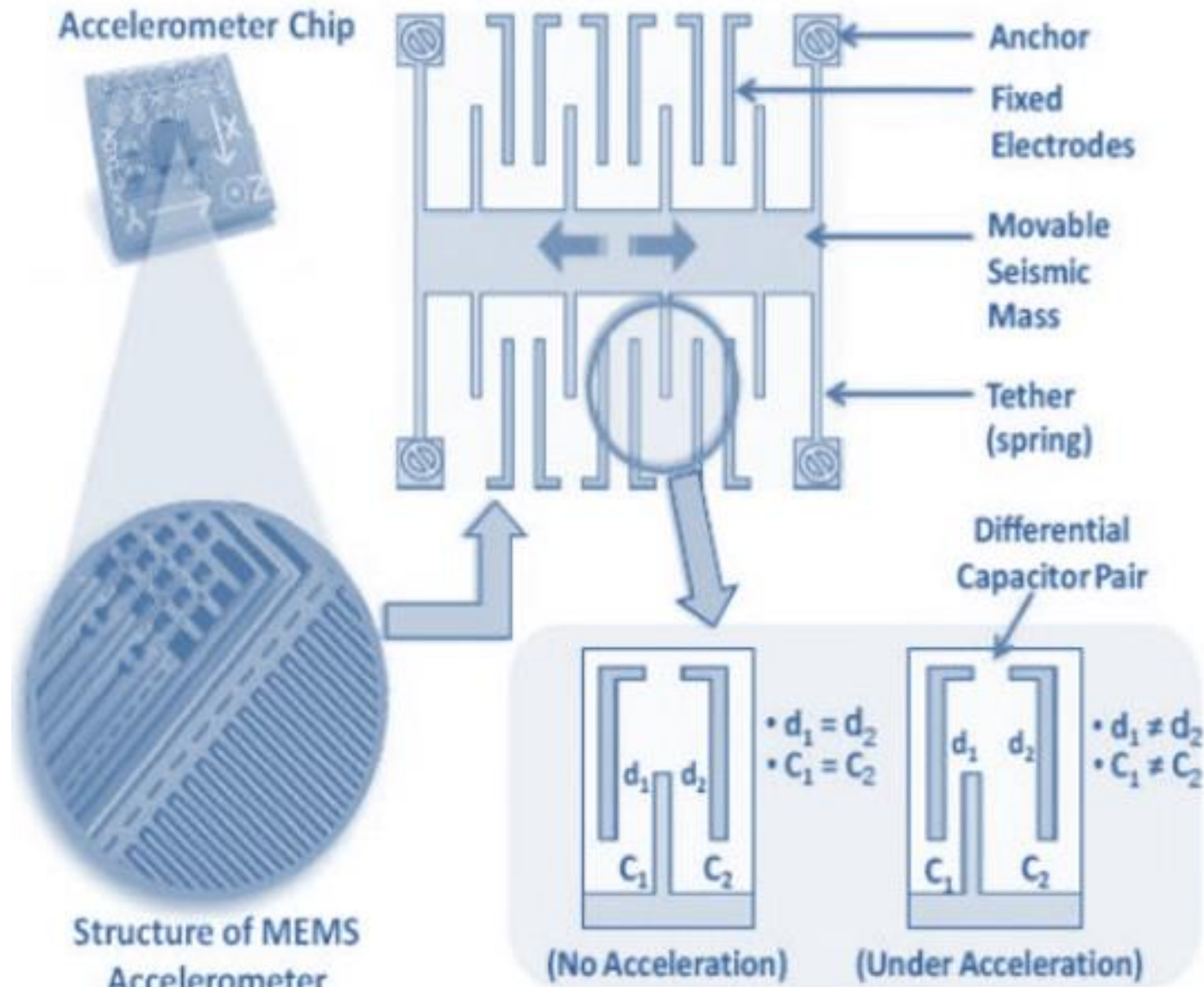
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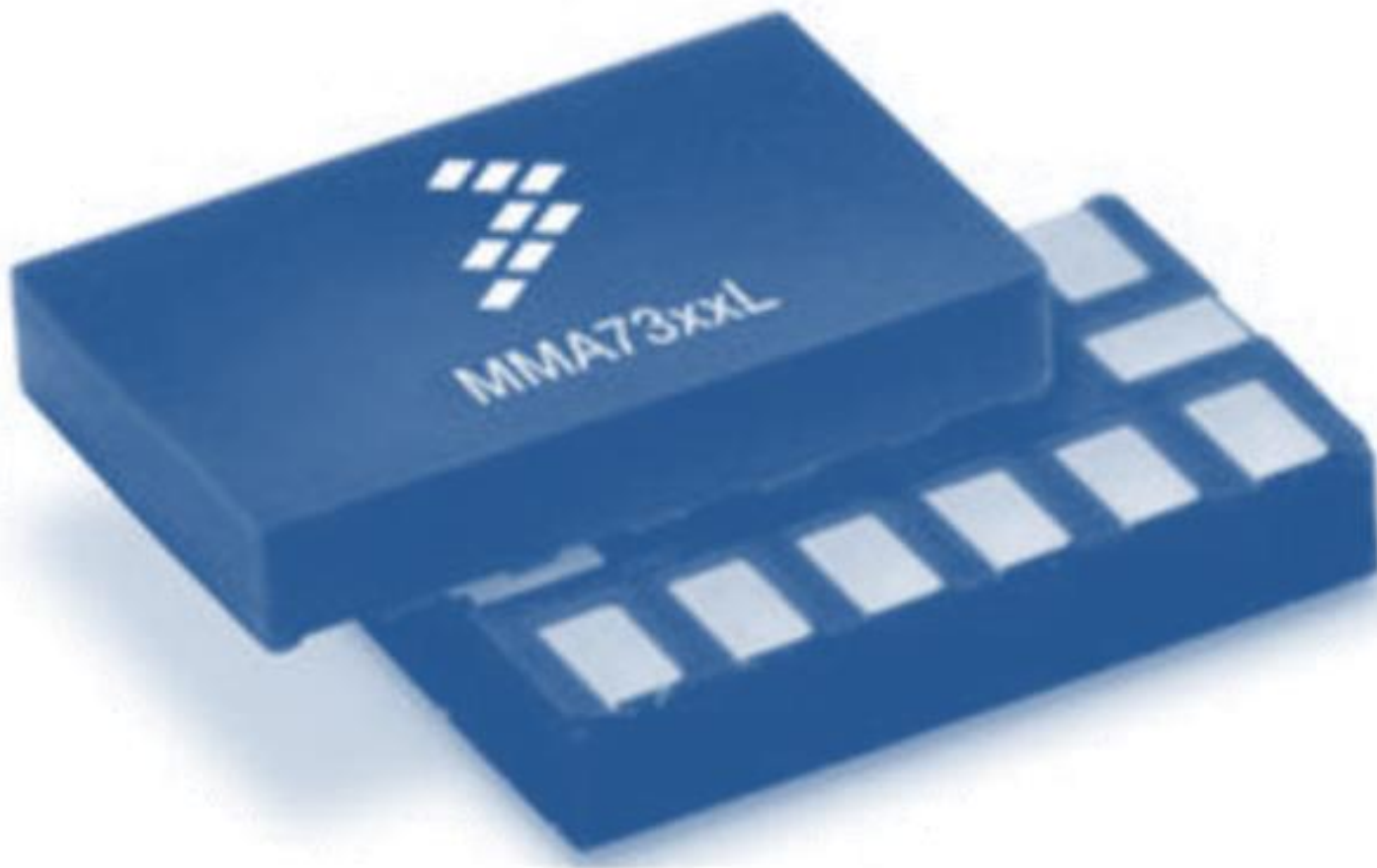




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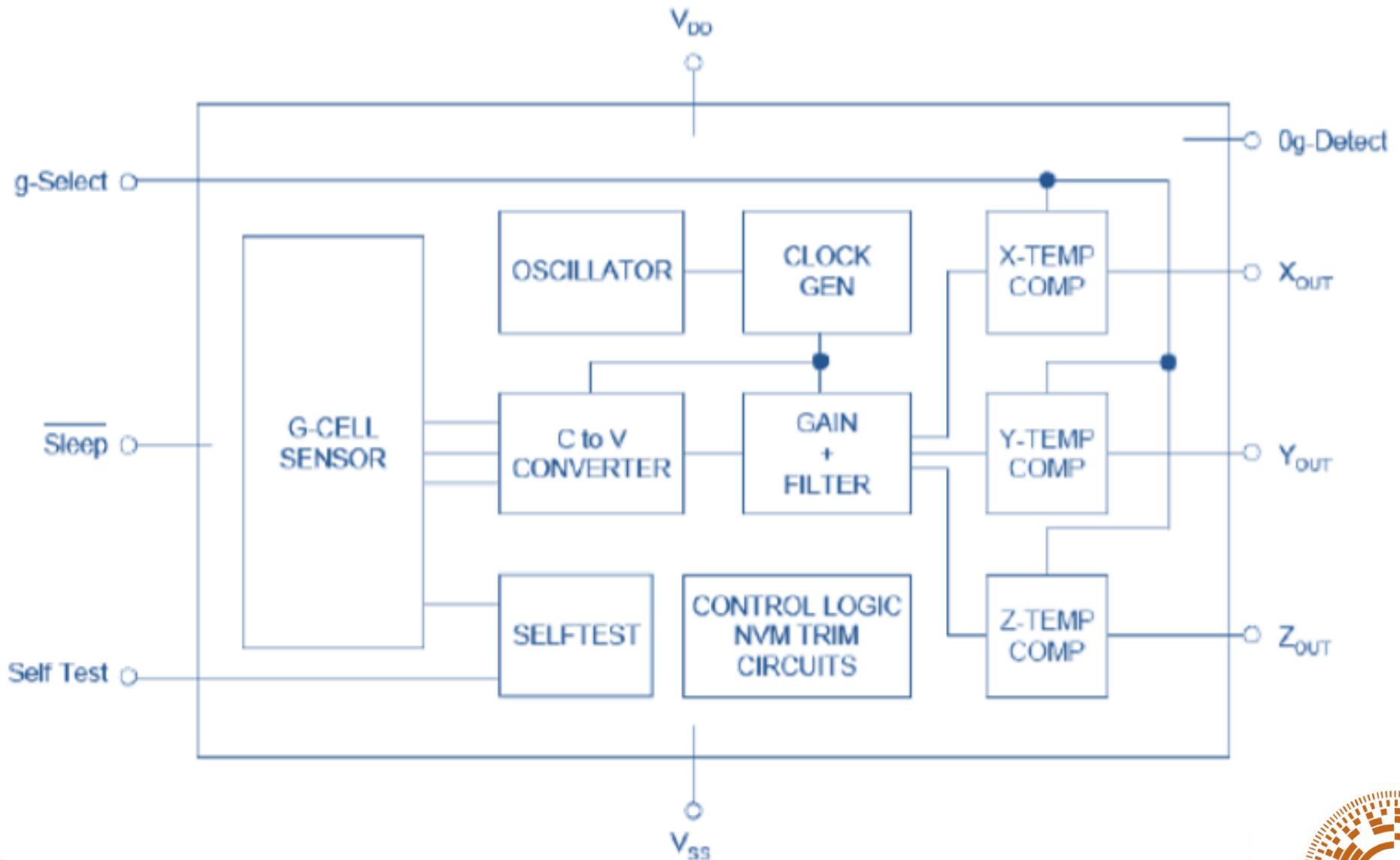


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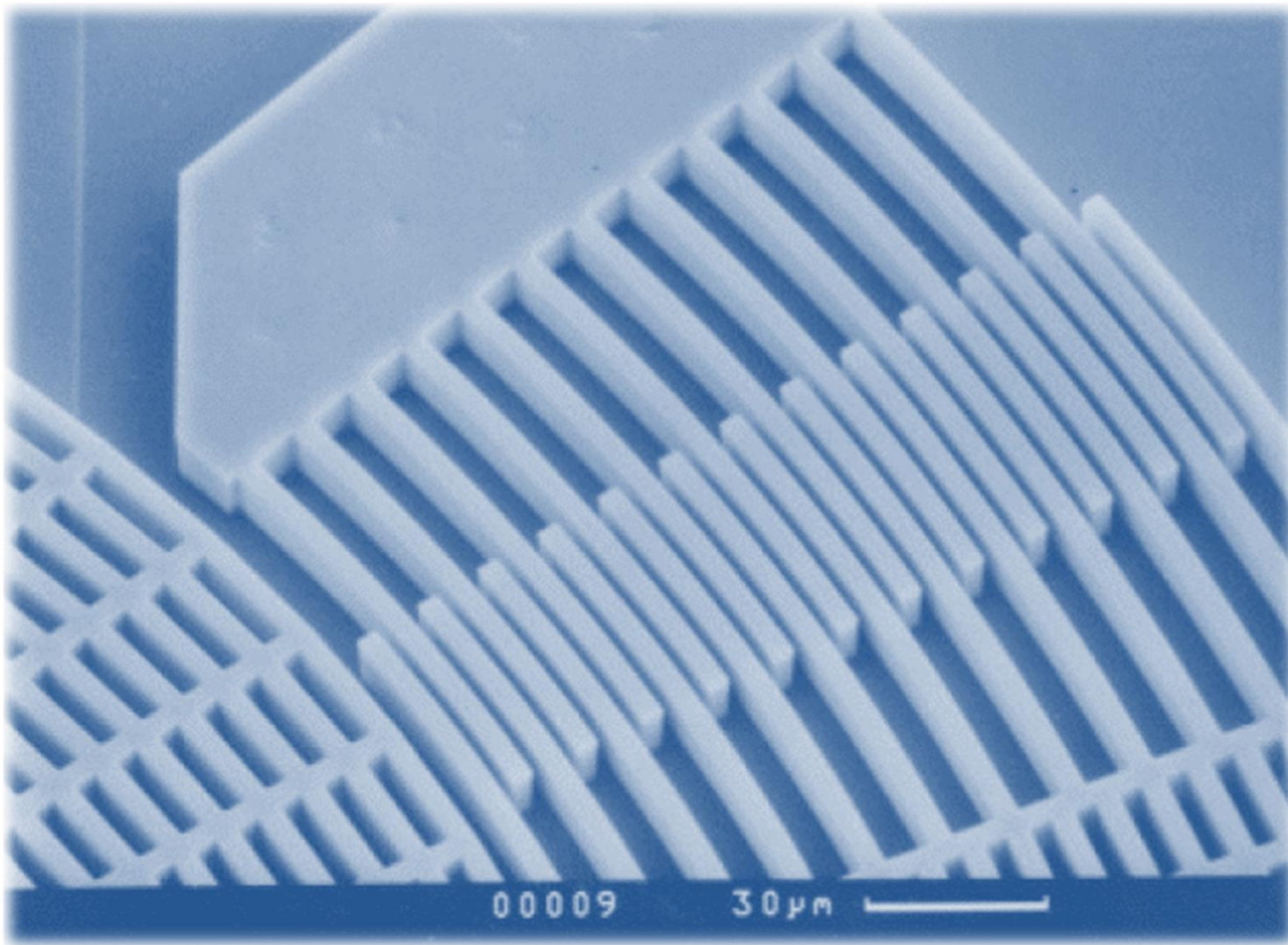




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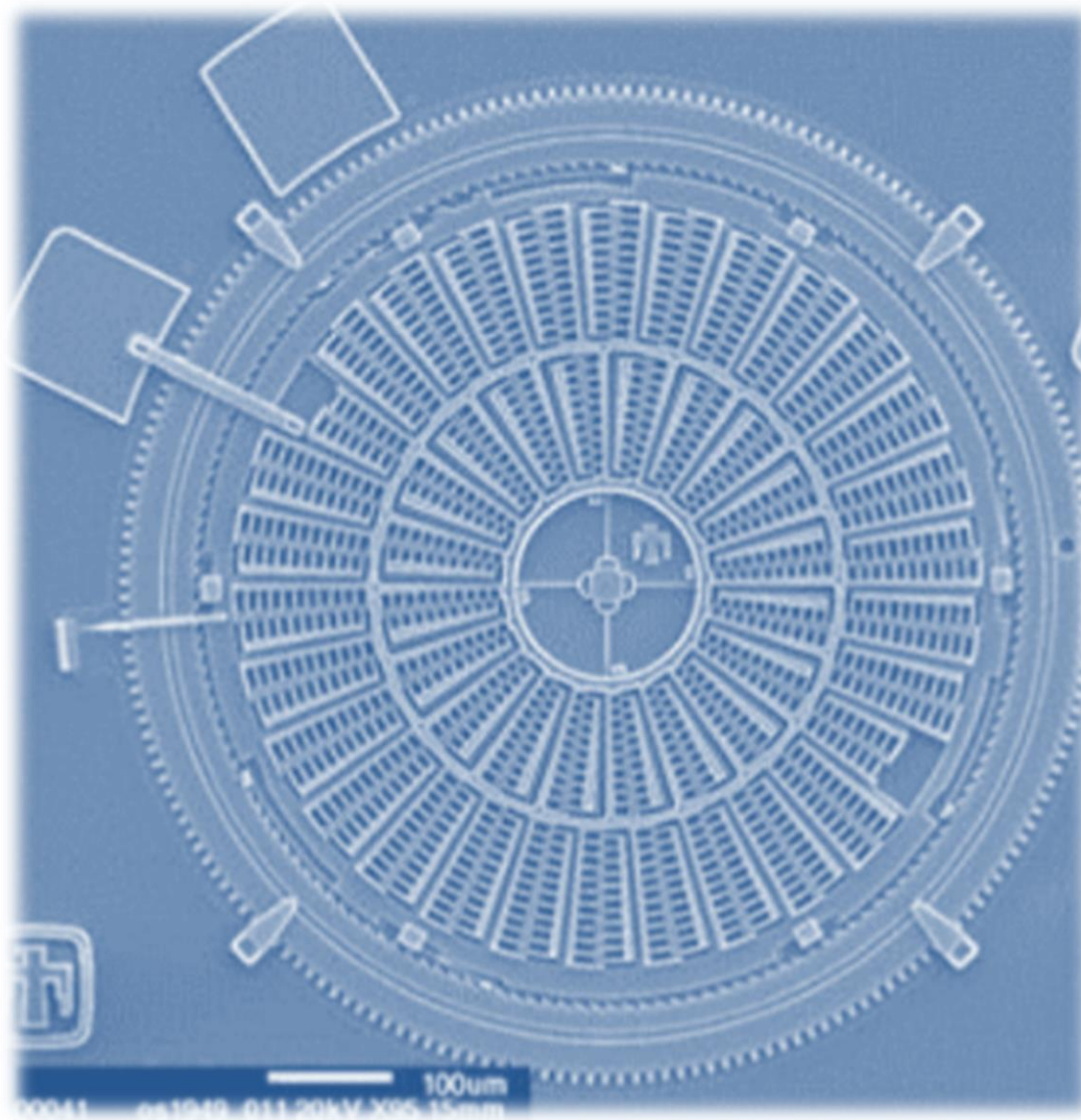


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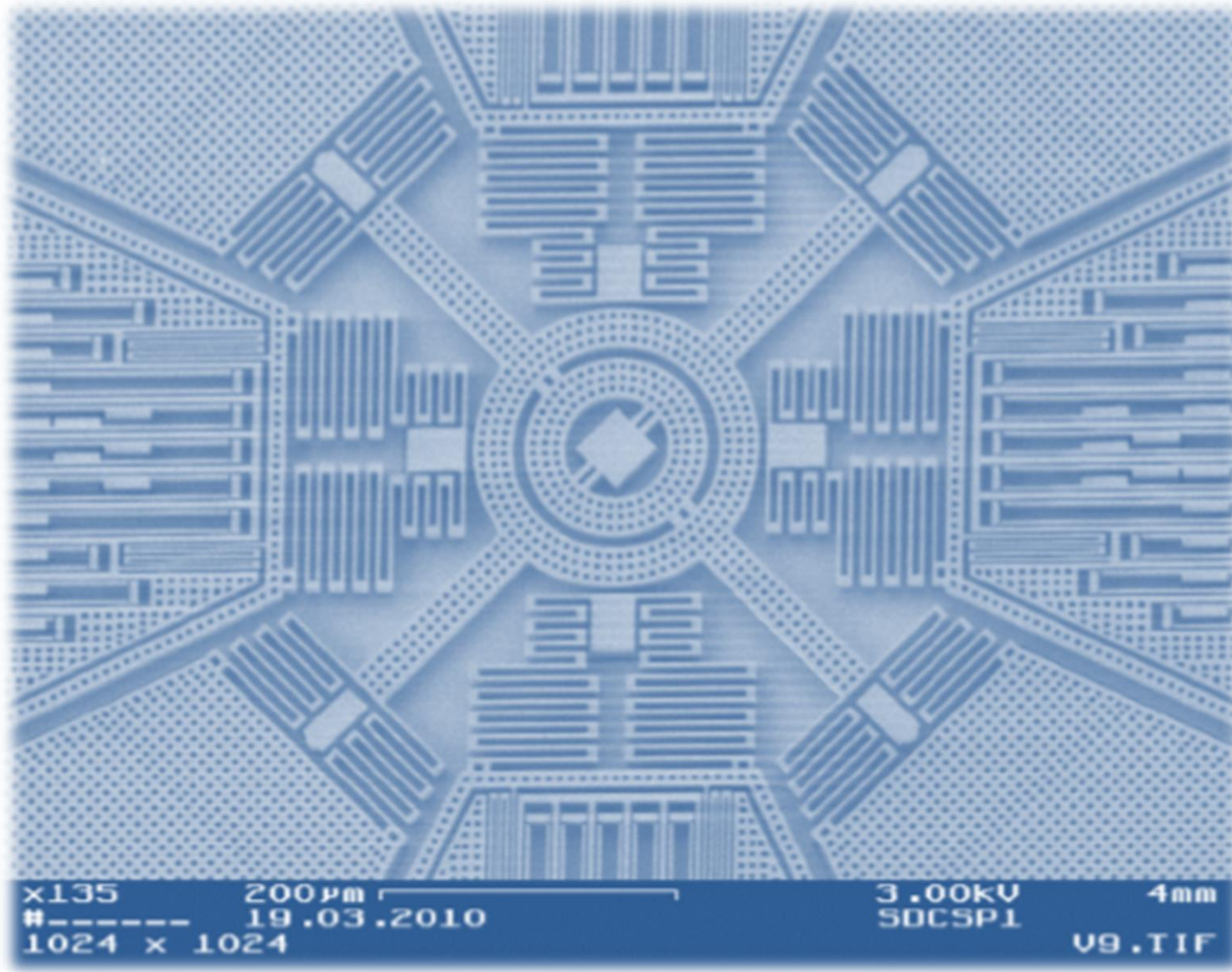


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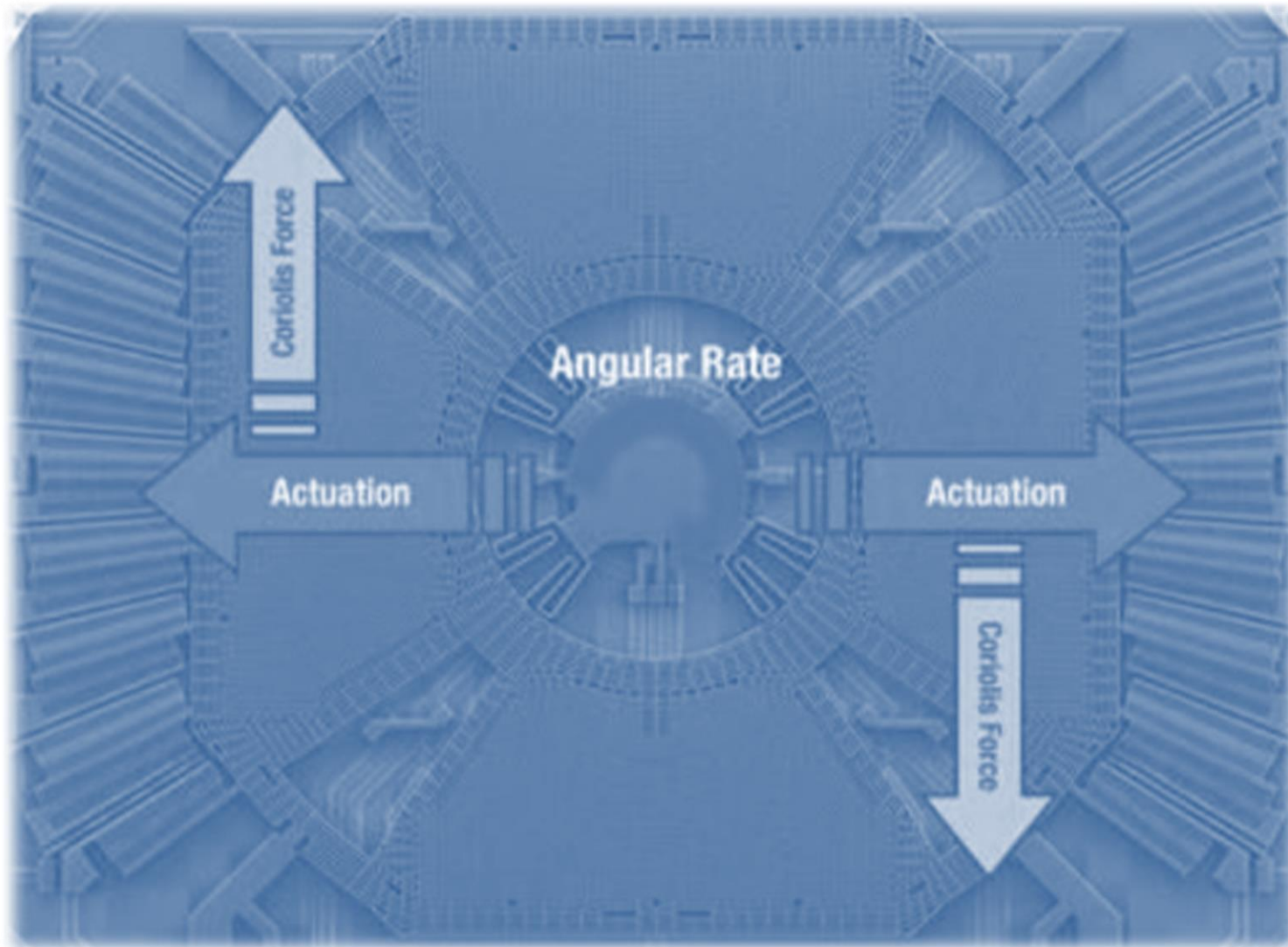




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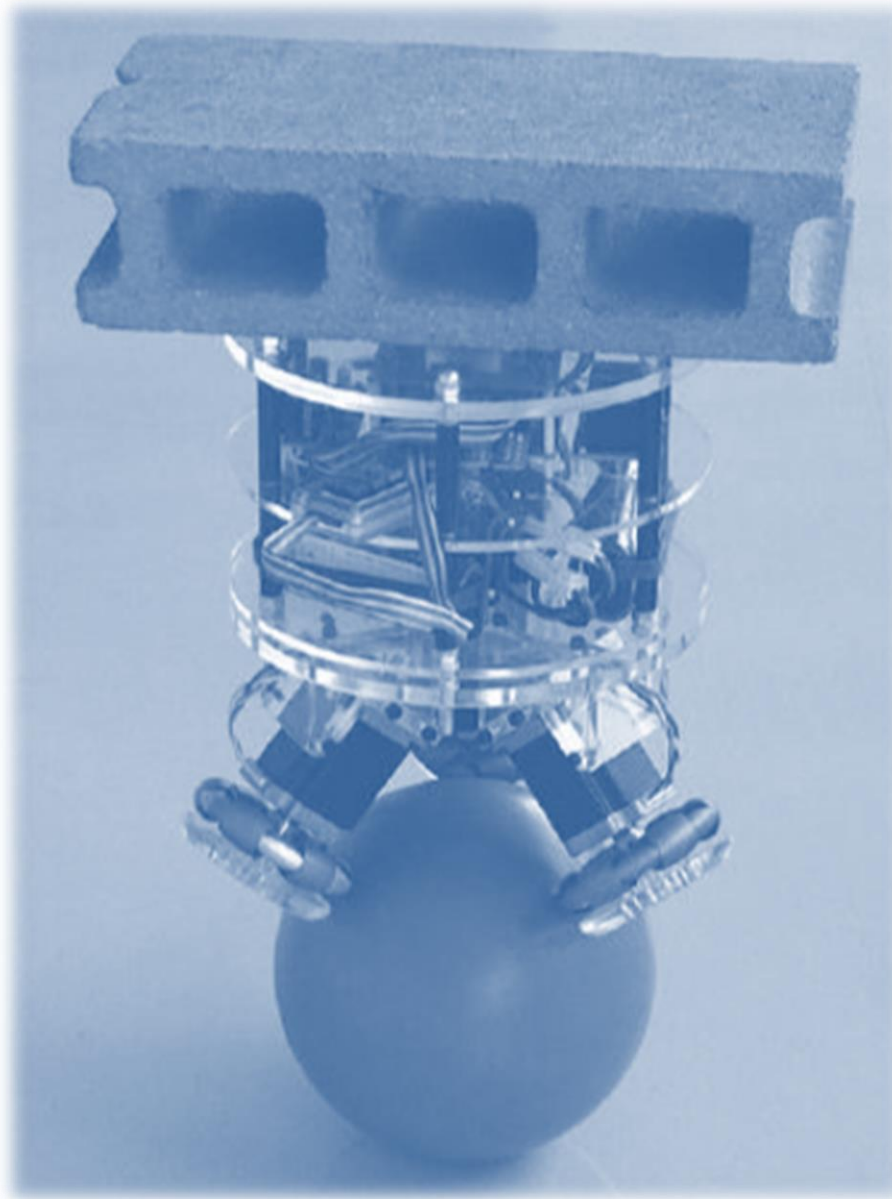


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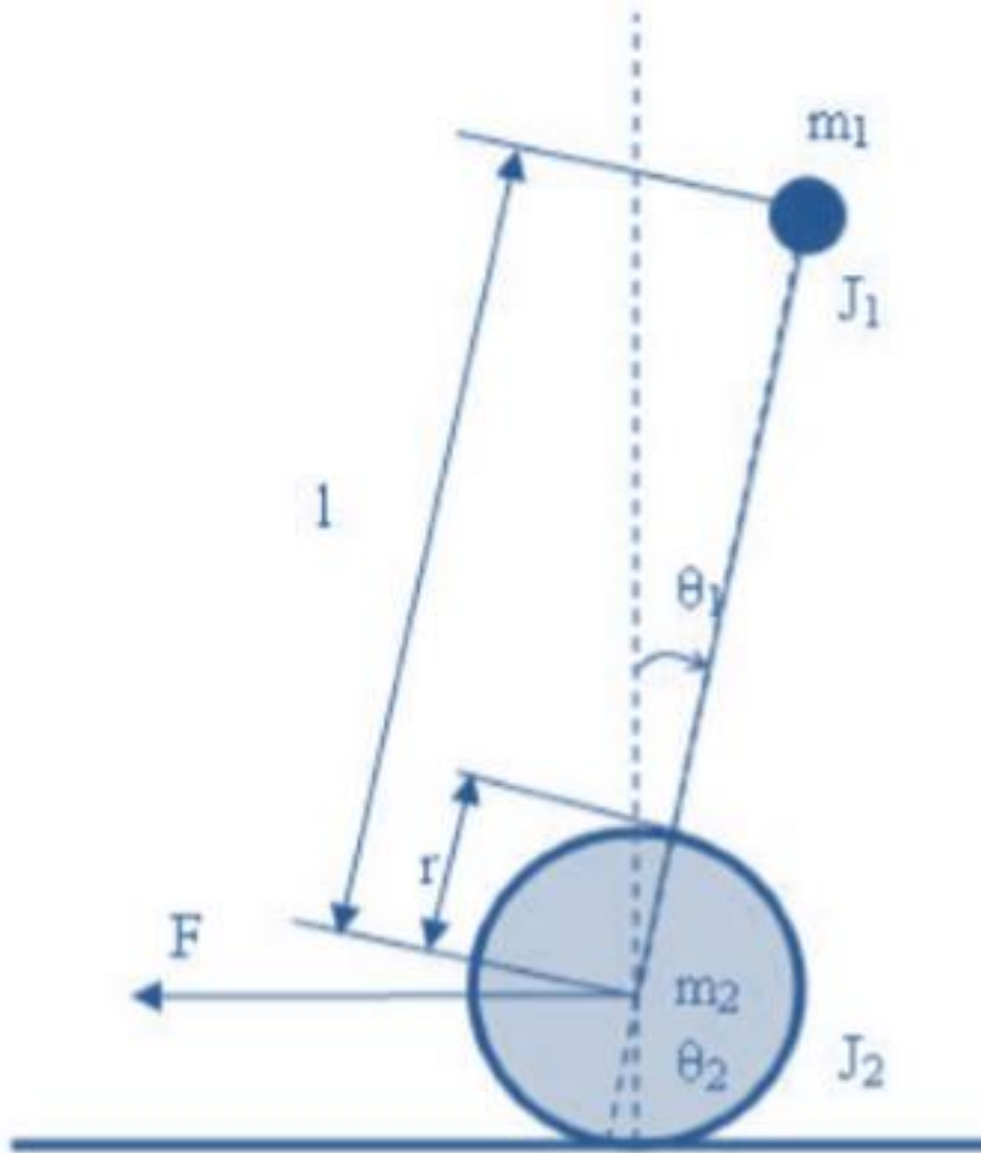




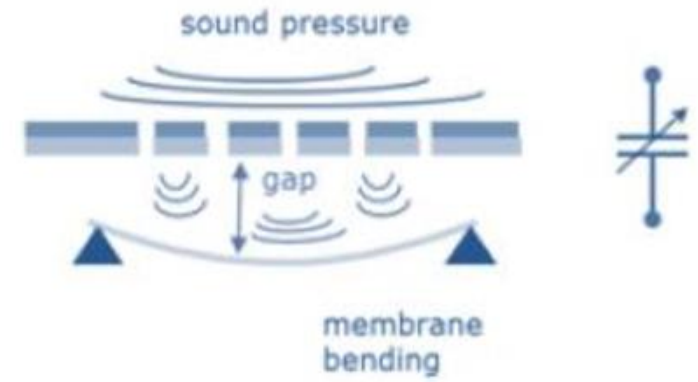
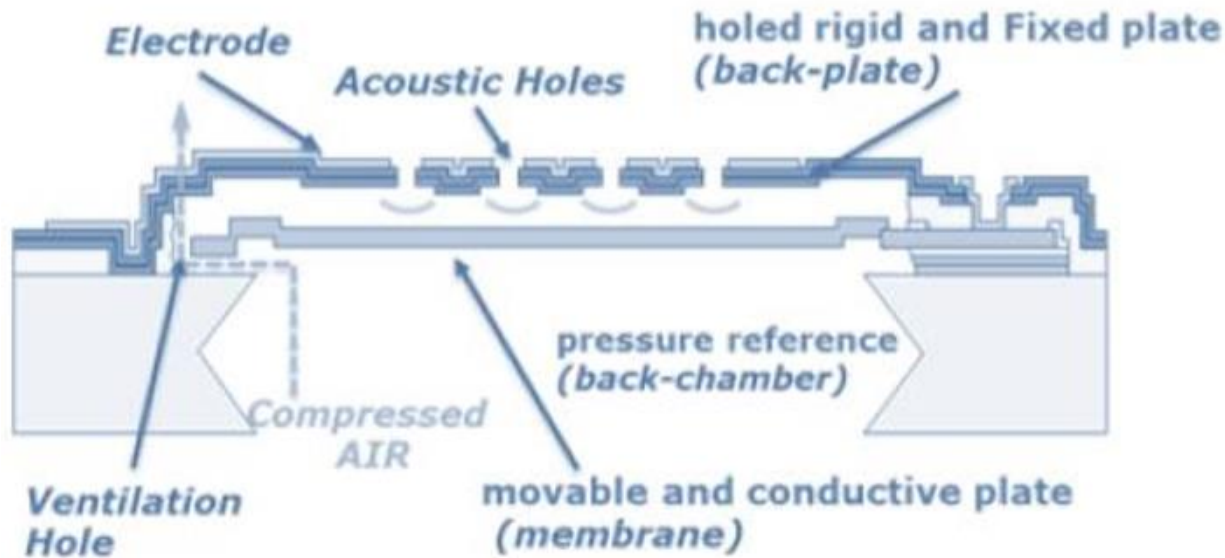
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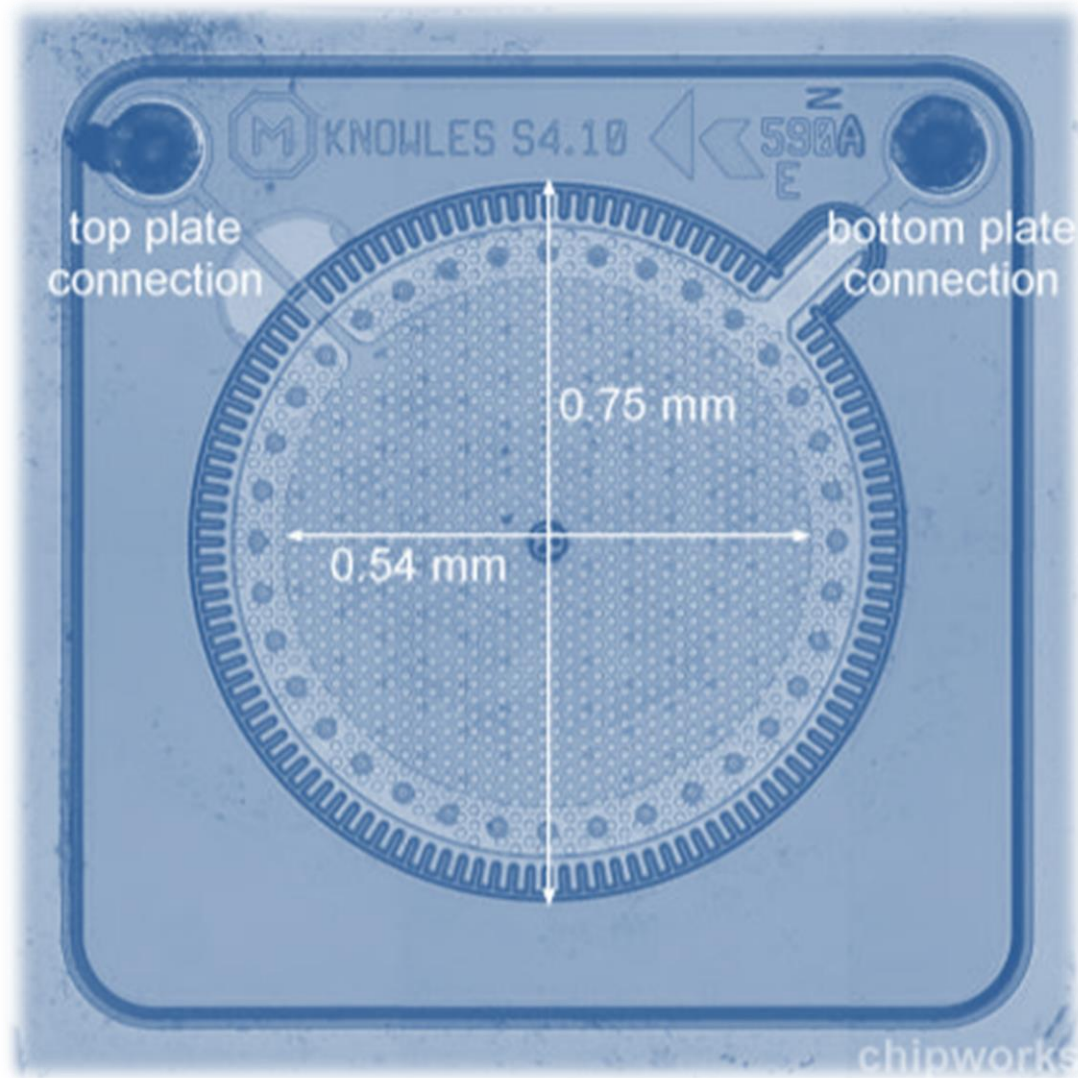




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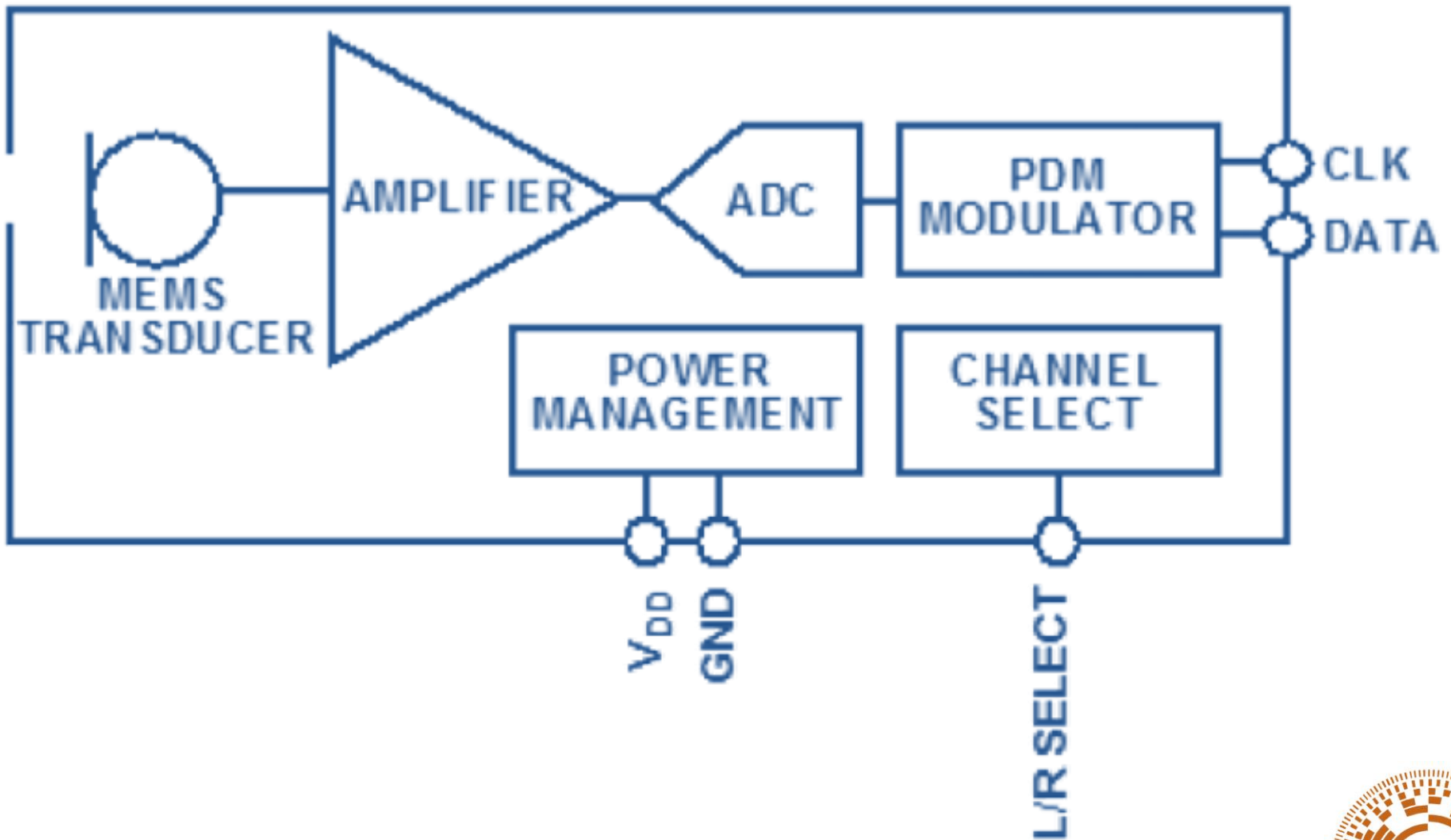


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